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Silect 1 di 1								
Form PTO-14 (REV. 1/06)	US Dept. of Con PATENT & TRADEMARK O	ept. of Commerce EMARK OFFICE		ATTY DOCKET NO. 127902		APPLICATION NO. 10/578,192		
INFORMATION DISCLOSURE STATEMENT								
(Use several sheets if necessary)				APPLICANTS Shigeru HANZAWA et al.			I <u>.</u>	
				FILING DATE May 4, 2006				
U.S. PATENT DOCUMENTS								
Examiner Initials	Cite No.	Document Number	Date		Name			
FOREIGN PATENT DOCUMENTS								
Examiner Initials	Cite No.	Document Number	Da	ıte	Country		With English Abstract	With English Translation
	1	JP B2 7-45348	5/17/199	15	Japan		х	х
	2	JP A 2001-524450	12/4/200	ю	Japan .		x	x
	3	WO 99/28268	6/10/1999		WIPO			
	4	JP A 2001-524451	12/4/200	)1	Japan		х	х
	5	WO 99/28269	6/10/199	19	WIPO			
	6	JP A 2001-527202	12/25/20	)01	Japan		х	х
	7	WO 99/32844	7/1/1999	,	WIPO			
	8	JP A 2001-519310	10/23/20	Ю1	Japan		X	х
	9	WO 99/18047	4/15/199	)9	WIPO			
	10	JP A 2001-525531	12/11/20	001	Japan		х	х
	11	WO 99/28689	6/10/199	)9	WIPO			
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Examiner Initials	Cite (Including Author, Title, Date, Pertinent Pages, etc.) No.							
EXAMINER /Daniel Bernstein/ Date Consider 10							ONSIDERED	7/2008
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Date: June 21, 2006